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Bib Data Sheet

CONFIRMATION NO. 2731

SERIAL NUMBER 09/869,912	FILING DATE 07/09/2001 RULE	CLASS 438	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. 110051
APPLICANTS Makoto Iida, Gunma, JAPAN; Masanori Kimura, Gunma, JAPAN; ** CONTINUING DATA ***** THIS APPLICATION IS A 371 OF PCT/JP00/07809 11/07/2000 ** FOREIGN APPLICATIONS ***** JAPAN 11-322487 11/12/1999				
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Not after Allowance Verified and Acknowledged <input checked="" type="checkbox"/> Examiner's Signature _____ Initials _____		STATE OR COUNTRY JAPAN	SHEETS DRAWING 1	TOTAL CLAIMS 1
INDEPENDENT CLAIMS 1				
ADDRESS Oliff & Berridge PO Box 19928 Alexandria, VA 22320				
TITLE Silicon single crystal wafer and production method thereof and soi wafer				
FILING FEE RECEIVED 878	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	